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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuyuki UNNO

Application No.: 09/523,735

Filed: March 13, 2000

For: PROJECTION OPTICAL SYSTEM  
AND PROJECTION EXPOSURE  
APPARATUS HAVING THE SAME

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Examiner: P. B. Kim

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Group Art Unit: 2851

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Confirmation No.: 7033

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May 25, 2004

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated February 25, 2004, please amend the above-identified application as follows: